



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shigeyuki Maruyama, et al.**

Confirmation No: **4823**

Serial No.: **09/577,932**

Group Art Unit: **2815**

Filed: **May 25, 2000**

Examiner: **Chris C. Chu**

For: **SEMICONDUCTOR DEVICE HAVING AN ALIGNMENT MARK FORMED BY THE SAME MATERIAL WITH A METAL POST**

Customer No.: **38834**

Fee

Attorney Docket No.: **000663**

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INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. §1.97(c)

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

July 16, 2004

Sir:

08/11/2004 TLAWRENCE 00000002 502866 09577932
01 FC:1806 The attention of the U.S. Patent and Trademark Office is hereby directed to the documents listed on the attached PTO/SB/08. A copy of each of these documents is attached.

This Information Disclosure Statement is being submitted after the issuance of a first official action on the merits and expiration of the three month period following the filing date or the entry in the national stage for the above-captioned application, but prior to the issuance of either a Final Office Action, Notice of Allowance, or an action that otherwise closes prosecution in the application.

The undersigned hereby certifies:

That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement and, to the knowledge of the person signing the certification after making reasonable inquiry, no

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